

Realize sustainable Acid Etch improvements

- ⊕ 20–30% reduction in free fluoride and 15–20% process time savings
- ⊕ Substantially lower fluoride and ammonia in wastewater
- ⊕ Ability to dispense fluoride and etch modifier independently
- ⊕ Outstanding scratch, die, and flow line hiding
- ⊕ Obtain consistent and uniform low gloss readings



 **BASF**
We create chemistry

Chemetall
expect more ⊕